



Solid State Bonded CVC SiC[®] for Large UVOIR Telescope Mirrors and Structures

Mirror Tech Days 2015

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Outline

- ◆ **Introduction**
- ◆ **Program Overview**
- ◆ **Status**
- ◆ **Follow-on Effort**
- ◆ **Conclusions**

Introduction

- ◆ **Trex's innovation for a type of Additive Manufacturing**
 - “Make Large Mirrors from Small Mirrors”
 - Additive manufacturing process significantly minimizes the cost and schedule of post-production fabrication steps (machining, polishing, metrology)
- ◆ **Effort addresses the need for large aperture, lightweight mirrors for future UV/Optical telescopes that will enable or enhance:**
 - Balloon-borne telescope missions
 - Discovery of habitable planets
 - Advances in solar physics
 - Study of faint structures around bright objects
- ◆ **Maturation of this technology will allow NASA and Trex to match and exceed the Chinese 4-meter monolithic silicon carbide mirror.**
- ◆ **Solid state bonded CVC SiC[®] components would also be used to produce components for the telescope opto-mechanical support structures.**

Program Effort

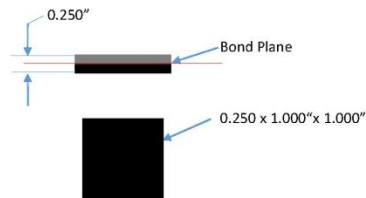
- ◆ **Demonstrate a novel ceramic joining technology (solid state bonding) that would allow large mirrors and structures to be made from smaller, easily manufactured, and simply shaped components.**
- ◆ **Characterize the solid state bonding process for CVC SiC[®].**
- ◆ **Optimize the bonding process for CVC SiC[®] with the goal of making the bond line/bond joint 100% pore-free.**
- ◆ **Demonstrate process scalability by manufacturing a subscale, lightweight, mirror prototype (technology demonstrator).**

Program Status

◆ Demonstration of solid state bonding technology

- Identified face- and edge-bonded sample geometries to facilitate bond line characterization and replicate meter-class lightweight mirror fabrication approach.

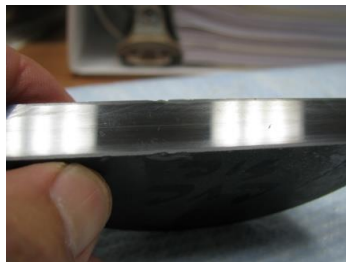
Face-Bonded Sample



Edge-Bonded Sample

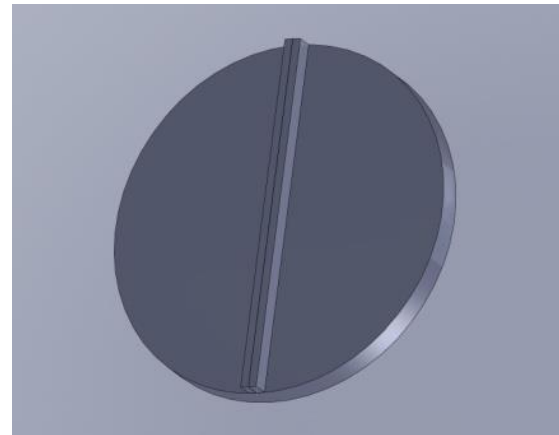
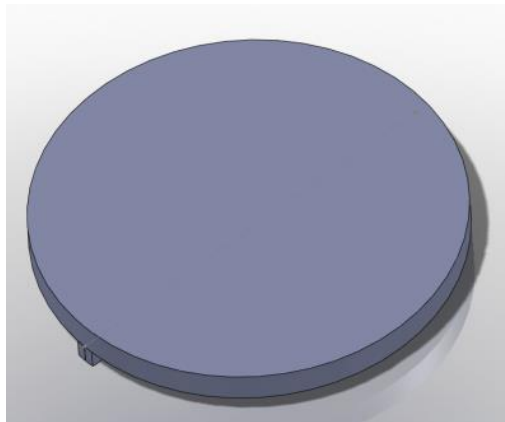


- Defined bonding parameters
 - Identified surface finish and surface flatness as primary attributes for examination.
 - One bonded sample for each finish/flatness condition in both face- and edge-bonding configuration.
- Early bonding demonstration on 3" diameter CVC SiC[®] discs.



Program Status, continued

- ◆ **Bonding sample and technology demonstrator fabrication complete.**
- ◆ **Characterization of bonding process for CVC SiC in process.**
- ◆ **Demonstration of process scalability**
 - Technology demonstrator: 5” diameter CVC SiC[®] bonded plano, rib-backed, specular front side polish.
 - To be compared side-by-side in thermal chamber with a 5” diameter CVC SiC[®] monolithic plano, rib-backed, specular front side finish.



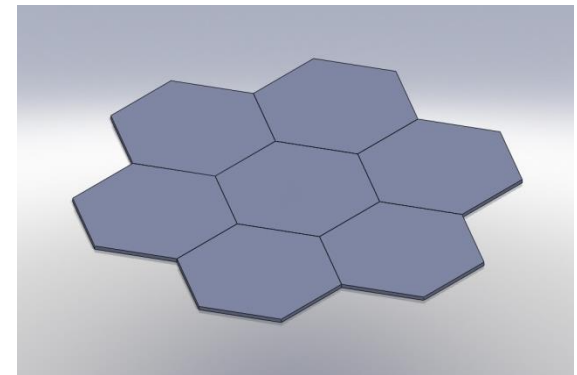
Outcome of Phase I and Proposed Phase II Effort

◆ Outcome of Phase I program

- Demonstration and characterization of solid state bonding for CVC SiC[®].

◆ Proposed Phase II Effort

- Optimization of CVC SiC[®] bonding process based on Phase I outcome.
- Evaluation of critical material properties (strength, flexure, etc.).
- Design and model a meter-class CVC SiC[®] mirror for space and balloon-borne telescopes.
- Produce a meter-class mirror prototype.



Conclusions

- ◆ **We have an additive manufacturing approach which dramatically reduces the cost for advanced optics and optical assemblies.**
- ◆ **Solid state bonding is a “pure” process - no bonding agents, additives, or adhesives.**
- ◆ **Capability to rapidly manufacturing of lightweight optics.**
- ◆ **Fast track to meter-class optics.**